

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

: Jesse D. Wolfe et al

Docket No.: IL-11072

Serial No. : 10/643,556

Art Unit:

1753

Filed

: August 18, 2003

Examiner:

Steven Versteeg

For

Process and Apparatus for Pulsed DC Matnetron Reactive Sputtering of Thin

Film Coatings on Large Substrates Using Smaller Sputter Cathodes

Commissioner for Patents Alexandria, VA 22313-1450

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## **AMENDMENT**

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Non Compliant Amendment mailed July 27, 2005 and the Office Action mailed January 12, 2005, please amend the above-referenced application as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Abstract begin on page 3 of this paper.

Amendments to the Claims begin on page 4 of this paper.

Remarks begin on page 10 of this paper.